PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Examiner:	Donghee Kang	
	Ali Keshavarzi et al.) Art Unit:	2811	
Application No.: 09/469,406)		deposited with first class mai	I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope	
Filed:	December 22, 1999		addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:	
For:	DECOUPLING CAPACITORS FOR THIN GATE OXIDES) —	//- 17 · 03 Date of Deposit	
Assignee: Intel Corporation)		Name of Name of Name	Name of Person Mailing Correspondence Del 11-17-03	
		Signature	Date	

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE

Sir:

This is in response to the non-final Office action dated August 15, 2003. Reconsideration of the application is requested. The application is not amended in this response.

REMARKS

Claims 29-50 are in the application of which claims 29 and 40 are in independent form. Claims 29-31, 35-36, 38-42, 46-47, and 49-50 are rejected and claims 32-34, 37, 43-45 and 48 Claims 29-31, 35-36, 38-42, 46-47, and 49-50 are rejected and claims 32-34, 37, 43-45 and 48 Claims 29-31, 35-36, 38-42, 46-47, and 49-50 are rejected and claims 32-34, 37, 43-45 and 48 Claims 29-31, 35-36, 38-42, 46-47, and 49-50 are rejected and claims 32-34, 37, 43-45 and 48 Claims 29-31, 35-36, 38-42, 46-47, and 49-50 are rejected and claims 32-34, 37, 43-45 and 48 Claims 29-31, 35-36, 38-42, 46-47, and 49-50 are rejected and claims 32-34, 37, 43-45 and 48 Claims

Claims 29-31, 35-36, 38-42, 46-47 & 49-50 stand rejected under 35 U.S.C. § 193(4) as being unpatentable over Manning et al. (US 5,962,887). For the following reasons, the should be withdrawn.

The rejection heading does not refer to the admitted prior art (APA) FIGS. 1 and 9, but the explanation of the rejection in the Office action does refer to the APA. The APA is relied by the Office action, pp. 2 and 3, to show that diffusion regions could be formed in the device body. Applicants admit that diffusion regions are well known in the technology. The Office action, pp.